CLAIMS

What is claimed is:

- 1. A system for predicting the lapping property of a lapping plate, comprising:
 - a rotatable platform;
 - a lapping plate mounted to the rotatable platform for rotation therewith;
 - a holder having a specimen mounted thereto and positioned on the lapping plate;
- a fixture positioned adjacent to the lapping plate, the fixture having a stationary base, an arm mounted to and extending away from the base toward the lapping plate, and a guide feature mounted to the arm for contacting and supporting the holder with respect to the lapping plate;

friction detection means mounted to the fixture for measuring frictional force between the lapping plate and the specimen; and

- a distance sensor mounted to the holder for detecting a gap distance between the distance sensor and the lapping plate.
- 2. The system of claim 1, wherein the lapping plate rotates for a specific time so that adequate removal of material from the specimen occurs, and a lapping rate is determined from a change in the gap distance over a time interval, and the lapping rate and friction are then assessed to determine if the lapping plate is acceptable.
- 3. The system of claim 1, wherein the system determines a lapping rate of the lapping plate under a fixed load and a fixed rotation speed, such that a coefficient of friction and a Preston coefficient of the lapping plate can be calculated.
- 4. The system of claim 1, wherein the distance sensor is a non-invasive sensor.
- 5. The system of claim 4, the distance sensor is an inductive distance sensor having a sensitivity of approximately 100 nm for a 10 mV sensor output.

- 6. The system of claim 1, wherein the guide feature comprises a set of guide wheels that keep the holder in place when the lapping plate is rotating.
- 7. The system of claim 1, wherein the specimen comprises a plurality of specimens that are symmetrically spaced apart about the distance sensor.
- 8. The system of claim 1, wherein the lapping plate is charged with abrasive.
- 9. The system of claim 1, wherein the specimen is formed from a material used to fabricate sliders.
- 10. The system of claim 1, further comprising a weight added to a top of the holder so that the specimen and the lapping plate experience a pressure that is analogous to a slider lapping pressure.
- 11. The system of claim 1, wherein the friction detection means is mounted to the arm.
- 12. The system of claim 1, wherein the friction detection means is a strain gage.

- 13. An apparatus for predicting the lapping property of a lapping plate, comprising: a rotatable platform adapted to support a lapping plate thereon for rotation therewith;
- a holder having a specimen mounted thereto and adapted to be positioned on top of the lapping plate;

a fixture having a stationary base, an arm mounted to and extending away from the base, and a guide feature mounted to the arm for contacting and horizontally supporting the holder with respect to the lapping plate;

friction detection means mounted to the fixture and adapted to measure frictional force between the lapping plate and the specimen;

a distance sensor mounted to the holder and adapted to detect a vertical gap distance between the distance sensor and the lapping plate; and

the rotatable platform being adapted to rotate the lapping plate for a specific time so that adequate removal of material from the specimen occurs, and a lapping rate is determined from a change in the gap distance over a time interval, and the lapping rate and friction are then assessed to determine if the lapping plate is acceptable.

- 14. The apparatus of claim 13, wherein the apparatus is adapted to determine the lapping rate of the lapping plate under a fixed load and a fixed rotation speed, such that a coefficient of friction and a Preston coefficient of the lapping plate can be calculated.
- 15. The apparatus of claim 13, wherein the distance sensor is a non-invasive sensor.
- 16. The apparatus of claim 15, wherein the distance sensor is an inductive distance sensor having a sensitivity of approximately 100 nm for a 10 mV sensor output.
- 17. The apparatus of claim 13, wherein the guide feature comprises a set of guide wheels that keep the holder in place when the lapping plate is rotating.

- 18. The apparatus of claim 13, wherein the specimen comprises a plurality of specimens that are symmetrically spaced apart about the distance sensor.
- 19. The apparatus of claim 13, wherein the specimen is formed from a material used to fabricate sliders.
- 20. The apparatus of claim 13, further comprising a weight added to a top of the holder so that the specimen and the lapping plate experience a pressure that is analogous to a slider lapping pressure.
- 21. The apparatus of claim 13, wherein the friction detection means is mounted to the arm.
- 22. The apparatus of claim 13, wherein the friction detection means is a strain gage.